

[illegible]

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) YKI-0078		Application Number 09/966,692	
				Applicant(s) Yamada			
				Group Art Unit 2312			

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>GM</i>		6,093,445	07/25/2000	Nawate			
<i>GM</i>		4,303,489	12/01/1981	Morrison, Jr.			

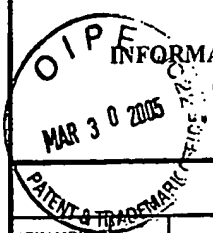
U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>GM</i>		JP2000068053	03-03-2000	Japan				
<i>GM</i>		EP 1128449	08-29-2001	CN, EP, JP, TW, US				

OTHER DOCUMENTS			(Including Author, Title, Date, Pertinent Pages, Etc.)
<i>GM</i>		EPO Search Report dated 08/31/05 re related Application No. EP 01 30 8327 English abstract for JP 2000068053	

EXAMINER <i>S. ...</i>	DATE CONSIDERED <i>1/19/06</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

 INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) YKI-0078		Application Number 09/966,692		
				Applicant(s) Yamada et al.				
				Filing Date 09/28/2001		Group Art Unit 2812		
U.S. PATENT DOCUMENTS								
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U.S. PATENT APPLICATION PUBLICATIONS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
SM		JP 2000-181086	06/30/2000	Japan				
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
SM		Office Action for Chinese Patent Application No. 011436867						
EXAMINER <i>[Signature]</i>				DATE CONSIDERED <i>6/6/05</i>				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								